



**ELECTRONIC COPY**

LG778669382  
Report verification at igi.org



March 25, 2026  
IGI Report Number **LG778669382**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **6.37 X 6.30 X 4.41 MM**  
**GRADING RESULTS**  
Carat Weight **1.55 CARAT**  
Color Grade **E**  
Clarity Grade **VVS 1**

March 25, 2026  
IGI Report Number **LG778669382**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **6.37 X 6.30 X 4.41 MM**

**GRADING RESULTS**

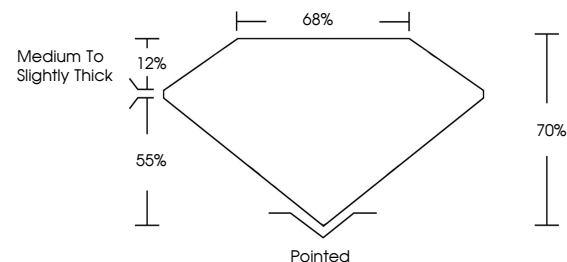
Carat Weight **1.55 CARAT**  
Color Grade **E**  
Clarity Grade **VVS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778669382**

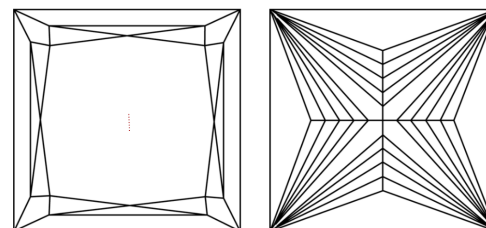
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

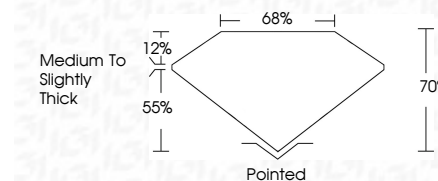
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778669382**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**

March 25, 2026  
IGI Report No. **LG778669382**  
**PRINCESS CUT**  
**6.37 X 6.30 X 4.41 MM**  
Carat Weight **1.55 CARAT**  
Color Grade **E**  
Clarity Grade **VVS 1**  
Depth **70%**  
Table **65%**  
Girdle **Medium to Slightly Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778669382**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa